



IFW

UNITED STATES PATENT AND TRADEMARK OFFICE

(Case No. 211.001-D4-US)

In the Application of: **Fazan et al.**

Serial No: **10/727,742**

Filed: **December 4, 2003**

Title: **Semiconductor Device**

) Group Art Unit: **2818**

) Before Examiner: **Son L. Mai**

)

)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on June 21, 2004  
Date

Michiko Sites  
(person signing this certificate)

Michiko Sites  
Signature

**AMENDMENT AND REPLY OF JUNE 21, 2004**

Dear Sir:

Kindly amend the application as follows: